

Attorney's Docket No.: 07977/192001/US3444

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hisashi Ohtani, et al. Art Unit : 2811  
 Serial No.: 08/958,568 Examiner : Hu, S.  
 Filed : October 28, 1997  
 Title : SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE  
 SAME

## BOX AF

Commissioner for Patents  
 Washington, D.C. 20231

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MAY 21 2002

AMENDMENT

Sir:

TECHNOLOGY CENTER 2800

In response to the Official Action dated December 21, 2001,  
 Paper No. 22, in the above-referenced application, kindly amend  
 the above-identified application as follows.

In the Claims:

Please cancel claims 62, 79-82, and 84 without prejudice.

Please amend the claims as follows.

61. (Amended) A display device comprising:  
 a semiconductor island comprising silicon provided on an  
 insulating surface;

## CERTIFICATE OF TRANSMISSION BY FACSIMILE

I hereby certify that this correspondence is being transmitted by  
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